

Laser Micromachining Services at Tel Aviv University



The ELAS Master Femto system:

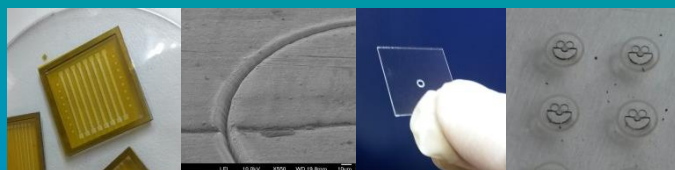
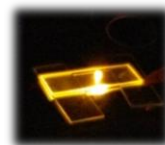
Precise laser micro machining is achieved by ultra-short laser pulses, precision of positioning stages and state of the art optics. In MASTER series workstations femtosecond laser pulses cause minimal heat-affected zone and maximize spatial precision.

Specifications :

- Three possible wavelengths: 1064nm, 532nm and 355nm.
- Pulse length 280 femtosecond.
- Power up to 10W.
- Pulse rate between 44KHz and 200KHz
- Stage Precision ± 1 micron.
- Spot size $2\mu\text{m}$ at 355nm, $30\mu\text{m}$ micron at 1064nm.
- Travel XY: 200mm Z: 100mm.
- Control by SCA software, can use DXF, PLT and STL files.

Machining Applications:

- Glass
- Thin metal sheets
- Si wafer cutting
- Polyimide (Kapton)
- PDMS
- Biopolymers
- Ceramics
- Silicon Nitride membranes
- Sapphire
- Diamond
- Carbon-fiber enforced resin



Contact:

Dr. Yigal Lilach

yigall@tauex.tau.ac.il

03-6405710/7209

For more information: <http://www.e-lasers.com/systems/master-series>